



AP/ITW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kozo SHIMIZU et al.**

Group Art Unit: **2812**

Serial No.: **10/771,391**

Examiner: **Lynne A. Gurley**

Filed: **February 5, 2004**

Confirmation No.: **3325**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE**

Attorney Docket Number: **042080**

Customer Number: **38834**

REQUEST FOR RECONSIDERATION AFTER FINAL

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

February 14, 2005

Sir:

In response to the Office Action dated December 8, 2004, Applicants request for reconsideration of the rejections of the above-identified application as submitted in the following remarks.

Remarks/Arguments begin on page 2 of this paper.